



Attorney Docket # 5367-69

AP/EPW

MS-AF

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Volker HARLE et al.

Serial No.: 10/780,317

Filed: February 17, 2004

For: Method for Fabricating a Plurality of
Semiconductor Bodies, and Electronic
Semiconductor Body

Examiner: Novacek, Christy L.
Group Art: 2822

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June 19, 2006
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Thomas Langer
Name of applicant, assignee or Registered Representative

Thomas Langer
Signature

June 19, 2006
Date of Signature

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Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

SIR:

In response to the final Office Action dated March 17, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.